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Attorney Docket No. 0756-2077

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/466,828

Filed: December 20, 1999

For: INSULATING FILM AND METHOD

OF PRODUCING SEMICONDUCTOR

DEVICE

) Group Art Unit: 2818

) Examiner: R. Berry

) CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 17, 2005.

) Adrian M. Stamp

**AMENDMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated June 20, 2005, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks** begin on page 9 of this paper.

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04 FC:1202 300.00 OP